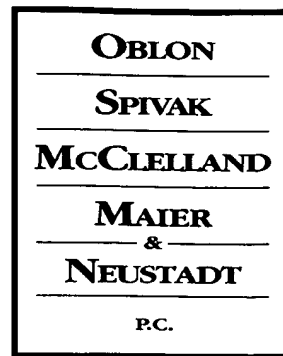




Docket No.: 216631US90



ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 09/994,827

Applicants: Kouji YOSHIDA

Filing Date: November 28, 2001

For: DESIGN METHOD FOR CONTROL SYSTEM,  
CONTROL SYSTEM, ADJUSTMENT METHOD FOR  
CONTROL SYSTEM, EXPOSURE METHOD, AND  
EXPOSURE APPARATUS

Group Art Unit: 2128

Examiner: Luu, Cuong V.

SIR:

Attached hereto for filing are the following papers:

### RESTRICTION RESPONSE

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

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DESIGN NO: 216631US90

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
KOUJI YOSHIDA : EXAMINER: LUU, CUONG V.  
SERIAL NO: 09/994,827 :  
FILED: NOVEMBER 28, 2001 : GROUP ART UNIT: 2128  
FOR: DESIGN METHOD FOR CONTROL :  
SYSTEM, CONTROL SYSTEM,  
ADJUSTMENT METHOD FOR CONTROL  
SYSTEM, EXPOSURE METHOD, AND  
EXPOSURE APPARATUS

RESTRICTION RESPONSE

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Restriction Requirement dated July 27, 2005, Applicant provisionally elects with traverse Group I, including Claims 1-25.

Applicant respectfully traverses the outstanding Restriction Requirement on the grounds set forth in MPEP § 803, which states "if the search and examination of an entire application can be made without serious burden, the Examiner must examine it on the merits, even though it includes claims to distinct or independent inventions."

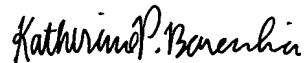
The claims of Groups I and II appear to part of an overlapping search area. Therefore, Applicant respectfully traverses the outstanding Restriction Requirement on the grounds that a search and examination of the entire application would not place a serious burden on the Examiner.

Moreover, although the outstanding Office Action uses the expressions “simulating” and “testing,” Applicant respectfully notes that these terms are not recited in Claims 1-40. Rather, Claims 1-25 are directed to a “design method” or an “adjusting method” and Claims 26-40 are addressed to an “exposure method” or an “exposure apparatus.”

Accordingly, it is respectfully requested that the requirement to elect a single group be withdrawn, and that a full examination on the merits of Claims 1-40 be conducted.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



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